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CONFIRMATION NO. 4693

<b>SERIAL NUMBER</b> 10/787,120	<b>FILING OR 371(c) DATE</b> 02/27/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2818	<b>ATTORNEY DOCKET NO.</b> 0756-7259
<b>APPLICANTS</b> Koichiro Tanaka, Atsugi-shi, JAPAN; Shunpei Yamazaki, Setagaya, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a CIP of 10/678,083 10/06/2003 ABN				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-054695 02/28/2003 JAPAN 2002-294305 10/07/2002				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 05/14/2004				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 19	<b>TOTAL CLAIMS</b> 17
<b>INDEPENDENT CLAIMS</b> 6				
<b>ADDRESS</b> 31780				
<b>TITLE</b> LASER IRRADIATION METHOD, LASER IRRADIATION APPARATUS, AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE				
<b>FILING FEE RECEIVED</b> 1762	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	